

Notice of References Cited	Application/Control No. 10/612,055	Applicant(s)/Patent Under Reexamination CHOI, MYUNG-RYUL	
	Examiner Nathan Danielsen	Art Unit 2627	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
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FOREIGN PATENT DOCUMENTS

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*	N	JP 11317065 A	11-1999	Japan	KIN et al.	
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NON-PATENT DOCUMENTS

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